

# A Fast Noise and $Z$ -Parameter Transformations Between Common Emitter and Common Base InP DHBT

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**Abstract**—A new approach has been developed that uses only a simple set of formulas to transform noise and  $Z$ -parameters between common emitter and common base configurations. This technique is based on the typical T-model of InP double-heterojunction bipolar transistor and calculated results agree with the experimental results, demonstrating that this approach is useful for many broad-band low-noise communication circuit designs.

**Index Terms**—Common base, common emitter, InP HBT, noise figure, noise parameters,  $Z$ -parameters.

## I. INTRODUCTION

AS IS commonly known, the noise performance for a common emitter (CE) and the common base (CB) configuration at very low frequencies is identical [1], [2]. However, there are some differences at RF and microwave frequency band due to the base–collector (BC) feedback capacitance of the CE configuration. A circuit configuration in the CE mode usually produces more noise than its CB counterpart. This is primarily due to its high input impedance that makes broad-band matching more difficult. A CB configuration has the advantages of ease of broad-band impedance matching, at better gain and a lower noise figure [3], [4]. Therefore, a CB configuration is generally more suitable for optical and microwave broad-band communication applications. However, current methods to calculate the CB noise parameters using available CE noise parameters are usually complicated and time consuming [5], [6]. In this paper, we propose a simple, yet effective transformation technique to convert the CE noise parameters into the CB noise parameters. Also, the transformations of the  $Z$ -parameters between the CE and CB configurations are presented. In this paper, an InP-based double-heterojunction bipolar transistor (DHBT) is used to illustrate this method.

## II. MODEL

### A. $Z$ -Parameter Transformation Between CE and CB

A typical T-model is used for the InP DHBT and its equivalent circuit in the CE configuration is shown in Fig. 1 [7]. The

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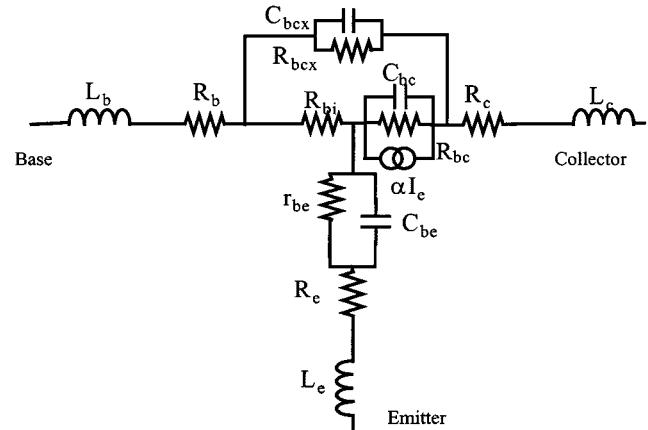


Fig. 1. T-model in CE configuration.

$Z$ -parameter expressions for the small-signal equivalent circuit of heterojunction bipolar transistors (HBTs) are derived in [8]. The extrinsic capacitances to ground are small for the devices using on-wafer probing. They are not suspected to significantly influence the results based on the analysis presented. Its corresponding small-signal equivalent circuit in the CB configuration can be obtained from rotating Fig. 1 by  $90^\circ$ . The  $Z$ -parameter expressions for the CB configuration are

$$Z_{11}^{\text{CB}} = z_E + z_B + \frac{(1 - \alpha)z_{BC}R_{bi} + z_F R_{bi}}{\Delta} \quad (1)$$

$$Z_{12}^{\text{CB}} = z_B + \frac{z_F R_{bi}}{\Delta} \quad (2)$$

$$Z_{21}^{\text{CB}} = z_B + \frac{\alpha z_{BC} z_F + z_F R_{bi}}{\Delta} \quad (3)$$

$$Z_{zz}^{\text{CB}} = z_C + z_B + \frac{(z_{BC} + R_{bi})z_F}{\Delta} \quad (4)$$

where  $\Delta = Z_{BC} + Z_F + R_{bi}$  and  $Z_{ij}^{\text{CB}}$  denotes CB  $Z$ -parameters.

Comparing the  $Z$ -parameters of the CE and the CB configurations, we can get the following relations:

$$Z_{11}^{\text{CB}} = Z_{11}^{\text{CE}} \quad (5)$$

$$Z_{12}^{\text{CB}} = Z_{11}^{\text{CE}} - Z_{12}^{\text{CE}} \quad (6)$$

$$Z_{21}^{\text{CB}} = Z_{11}^{\text{CE}} - Z_{21}^{\text{CE}} \quad (7)$$

$$Z_{22}^{\text{CB}} = Z_{11}^{\text{CE}} + Z_{22}^{\text{CE}} - Z_{12}^{\text{CE}} - Z_{21}^{\text{CE}} \quad (8)$$

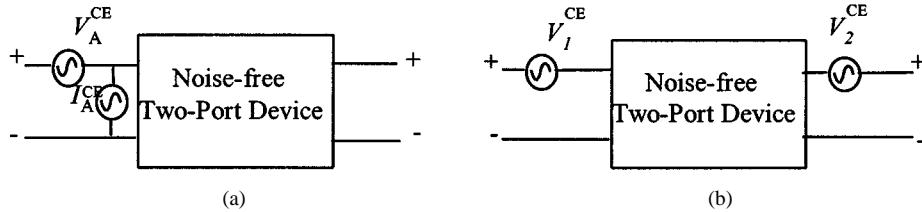


Fig. 2. (a) Two-port device of a CE HBT with its noise represented by equivalent input sources: one current gerentor and one voltage gerentor. (b) Two-port device of a CE HBT with its noise represented by equivalent input sources: two voltage gerentors.

and the  $ABCD$ -parameter transformations

$$A^{\text{CB}} = \frac{A^{\text{CE}}}{A^{\text{CE}} - 1} \quad (9)$$

$$C^{\text{CB}} = \frac{C^{\text{CE}}}{A^{\text{CE}} - 1} \quad (10)$$

where  $Z_{ij}^{\text{CE}}$  denotes the CE  $Z$ -parameters, and  $A^{\text{CB}}$ ,  $C^{\text{CB}}$  and  $A^{\text{CE}}$ ,  $C^{\text{CE}}$  denote the  $ABCD$ -parameters of the CB and CE configurations, respectively.

### B. Noise Parameter Transformation Between CE and CB

Fig. 2(a) shows the two-port device of a CE HBT with its noise represented by an equivalent input source: a current generator and a voltage generator. These sources and their correlation coefficient completely characterize the noise of the device. Normally these sources are specified by the following standard set of noise parameters [9]:

$$R_n^{\text{CE}} = \frac{\langle \bar{v}_A^2 \rangle}{4kT_0} \quad (11)$$

$$G_n^{\text{CE}} = \frac{\langle \bar{i}_A^2 \rangle}{4kT_0} \quad (12)$$

$$Y_{\text{cor}}^{\text{CE}} = G_{\text{cor}}^{\text{CE}} + jB_{\text{cor}}^{\text{CE}} = \frac{\langle i_A v_A^* \rangle}{\langle \bar{v}_A^2 \rangle}. \quad (13)$$

These parameters are known as the noise resistance, noise conductance, and correlation admittance, respectively. The Boltzmann's constant and reference temperature are denoted by  $k$  and  $T_0$ , respectively. The noise sources are defined in terms of spectral densities, i.e., volts and amperes per root hertz. In terms of these parameters, the noise figure of the device is given by [9]

$$F^{\text{CE}} = F_{\text{MIN}}^{\text{CE}} + \frac{R_n^{\text{CE}}}{G_s} \left| Y_s - \left( G_{\text{opt}}^{\text{CE}} + jB_{\text{opt}}^{\text{CE}} \right) \right|^2 \quad (14)$$

where  $Y_s = G_s + jB_s$  is the admittance of the source, and

$$G_{\text{opt}}^{\text{CE}} = G_{\text{cor}}^{\text{CE}} + \frac{G_n^{\text{CE}}}{R_n^{\text{CE}}} \quad (15)$$

$$B_{\text{opt}}^{\text{CE}} = -B_{\text{cor}}^{\text{CE}} \quad (16)$$

and

$$F_{\text{MIN}}^{\text{CE}} = 1 + 2R_n^{\text{CE}} \left( G_{\text{opt}}^{\text{CE}} + G_{\text{cor}}^{\text{CE}} \right). \quad (17)$$

Fig. 2(a) shows that the voltage and current noise sources  $V_A^{\text{CE}}$  and  $I_A^{\text{CE}}$ , the  $ABCD$ -matrix description, will be more

convenient for this linear two-port noise network. This representation is as follows:

$$V_1 = AV_2 + BI_2 + V_A^{\text{CE}} \quad (18)$$

$$I_1 = CV_2 + DI_2 + I_A^{\text{CE}}. \quad (19)$$

Fig. 2(b) shows the two noise voltage sources at the input and output of the linear two-port noise network; it is relatively easy to derive the expressions in the impedance form as follows:

$$V_1 = Z_{11}I_1 + Z_{12}I_2 + V_1^{\text{CE}} \quad (20)$$

$$V_2 = Z_{21}I_1 + Z_{22}V_1 + V_2^{\text{CE}}. \quad (21)$$

Comparing (17) and (18) with (19) and (20), we can obtain (22) and (23) as follows:

$$V_1^{\text{CE}} = V_A^{\text{CE}} - \frac{A^{\text{CE}}}{C^{\text{CE}}} I_A^{\text{CE}} \quad (22)$$

$$V_2^{\text{CE}} = -\frac{I_A^{\text{CE}}}{C^{\text{CE}}} \quad (23)$$

where  $A^{\text{CE}}$  and  $C^{\text{CE}}$  denote the  $ABCD$ -parameters of the two-port device of a CE HBT. Using the method of [5], the CB noise voltage sources  $V_1^{\text{CB}}$  and  $V_2^{\text{CB}}$  are derived as

$$V_1^{\text{CB}} = -V_1^{\text{CE}} \quad (24)$$

$$V_2^{\text{CB}} = V_2^{\text{CE}} - V_1^{\text{CE}} \quad (25)$$

and the voltage and current noise sources  $V_A^{\text{CB}}$  and  $V_A^{\text{CE}}$  for the CB configuration are similarly obtained as

$$V_A^{\text{CB}} = V_1^{\text{CB}} - A^{\text{CB}} V_2^{\text{CB}} = \frac{V_A^{\text{CE}}}{A^{\text{CE}} - 1} \quad (26)$$

$$I_A^{\text{CB}} = -C^{\text{CB}} V_2^{\text{CB}} = \frac{C^{\text{CE}}}{A^{\text{CE}} - 1} V_A^{\text{CE}} - I_A^{\text{CE}} \quad (27)$$

where  $A^{\text{CB}}$  and  $C^{\text{CB}}$  denote the  $ABCD$ -parameters of the two-port device of the CB HBT. Using the definitions of (11)–(13), the CB noise parameters are obtained after some simple calculations as

$$R_n^{\text{CB}} = \frac{R_n^{\text{CE}}}{|A^{\text{CE}} - 1|^2} \quad (28)$$

$$G_n^{\text{CB}} = \left| \frac{C^{\text{CE}}}{A^{\text{CE}} - 1} \right|^2 R_n^{\text{CE}} + G_n^{\text{CE}} - 2\text{Re} \left[ \frac{C^{\text{CE}}}{A^{\text{CE}} - 1} R_n^{\text{CE}} Y_{\text{cor}}^{\text{CE}*} \right] \quad (29)$$

$$Y_{\text{cor}}^{\text{CB}} = C^{\text{CE}} - (A^{\text{CE}} - 1) Y_{\text{cor}}^{\text{CE}} \quad (30)$$

where  $R_n^{\text{CE}}$ ,  $G_n^{\text{CE}}$ ,  $Y_{\text{cor}}^{\text{CE}}$  and  $R_n^{\text{CB}}$ ,  $G_n^{\text{CB}}$ ,  $Y_{\text{cor}}^{\text{CB}}$  are the noise resistance, noise conductance, and correlation admittance of the CE and the CB configurations, respectively.

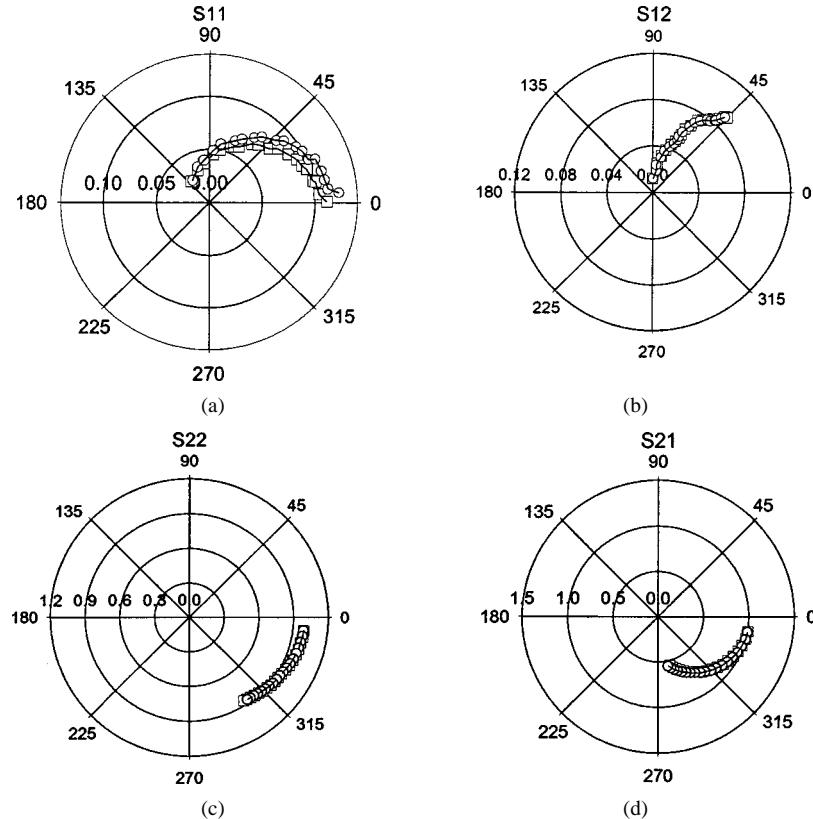


Fig. 3. Measured (□) and calculated (○) CB  $S$ -parameters versus frequency at  $V_{CB} = 0.84$  V or  $V_{CE} = 1.5$  V and  $I_C = 3.9$  mA.

### III. EXPERIMENTAL RESULTS

To verify the accuracy of the above noise transformation expressions, InP/InGaAs DHBTs in the CE and CB mode with an emitter area of  $5 \times 20 \mu\text{m}^2$  were used in this study. Details of the device structure and performance were described in [10]. These CE devices showed an average extrinsic peak current gain of 180. The ideality factors of the collector and base currents were  $\sim 1.1$  and  $\sim 1.2$ , respectively. The devices possess very low leakage current with a high CE breakdown voltage ( $BV_{CEO} > 9$  V). The CE devices have a typical current gain cutoff frequency ( $f_T$ ) of 61 GHz and maximum oscillation frequency ( $f_{\max}$ ) of 38 GHz. The  $5 \times 20 \mu\text{m}^2$  CB devices have a typical maximum oscillation frequency ( $f_{\max}$ ) of 72 GHz.

The microwave noise parameters were measured from 2 to 20 GHz. The measurement system consisted of an ATN-NP5 wafer probe test set, HP8970C noise-figure test set, HP8970B noise-figure meter, and HP8510C network analyzer, and the signal source for the noise figure test set is shared with HP8510C. The minimum noise figure, noise resistance, and the optimal source impedance ( $NF_{\min}$ ,  $R_N$ ,  $G_{\text{OPT}}$ , and  $B_{\text{OPT}}$ ) were extracted from the measured noise figure and  $S$ -parameters at a particular dc bias for these devices in the CE and CB configuration. Fig. 3 shows the comparison of the measured and calculated  $S$ -parameters of the CB configurations using (5)–(8) and  $S$ – $Z$  transformations based on the CE small-signal parameters at  $V_{CB} = 0.84$  V or  $V_{CE} = 1.5$  V and  $I_C = 3.9$  mA. Fig. 4 shows the comparison of the measured and calculated noise figure of the CB configuration using (15)–(17), (28)–(30) and CE noise figure at the same bias conditions. Good agreement

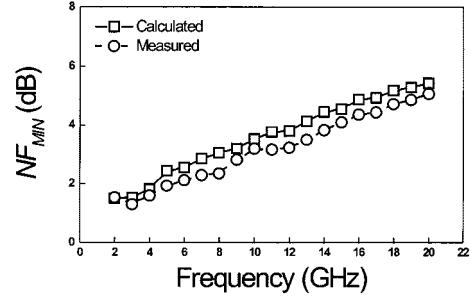


Fig. 4. Measured (□) and calculated (○) CB noise figure versus frequency.

between the measured and calculated  $S$ -parameter and minimum noise figure from 2 to 20 GHz were obtained. To further illustrate the effectiveness and accuracy of this approach, we also compared the measured  $R_n^{\text{CB}}$  and calculated  $R_n^{\text{CB}}$  from the measured  $R_n^{\text{CE}}$  at the same bias conditions. As shown in Fig. 5, good agreement is observed between the measured and calculated results despite the fact that the equivalent noise resistance is a difficult parameter to obtain because of the uncertainty in the  $S$ -parameter measurement. Figs. 6 and 7 show the measured real part ( $G_{\text{opt}}^{\text{CB}}$ ) and imaginary part ( $B_{\text{opt}}^{\text{CB}}$ ) of the optimum input admittance and the calculated  $G_{\text{opt}}^{\text{CB}}$  and  $B_{\text{opt}}^{\text{CB}}$  from the measured  $G_{\text{opt}}^{\text{CE}}$  and  $B_{\text{opt}}^{\text{CE}}$  at the same bias conditions. Although good agreement between the calculated and measured real part of the optimum input admittance was obtained, the errors between the measured and calculated real part increase with increasing frequency. This possible reason is that the measured errors are caused due to very small values of the imaginary part of the optimum input admittance.

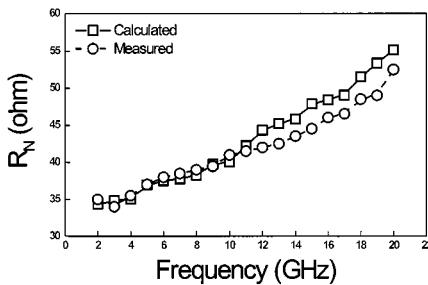


Fig. 5. Measured (□) and calculated (○) CB noise resistance versus frequency.

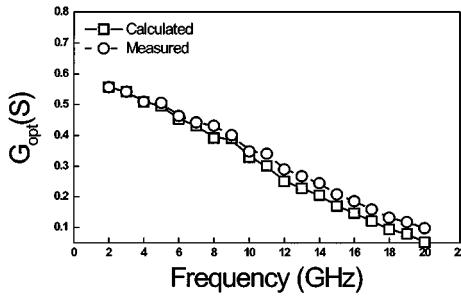


Fig. 6. Measured (□) and calculated (○) CB real part of the optimum input admittance versus frequency.

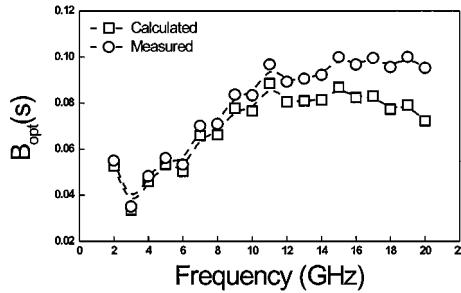


Fig. 7. Measured (□) and calculated (○) CB imaginary part of the optimum input admittance versus frequency.

#### IV. SUMMARY

A set of formulas for quick noise parameter transformations based on the  $ABCD$  representation for the CE and CB configurations has been presented. The simplified transformations of the  $Z$ -parameters between the CE and CB configurations have also been obtained. The measured microwave noise performances of an InP-based DHBT for the CB and CE configurations have been demonstrated to confirm these transformation. At the frequency range of 2–20 GHz, good agreements between the measured and calculated results of noise and  $S$ -parameters were obtained. This shows that the new approach for fast noise and  $Z$ -parameters transformations can be used for the application of the low noise and broad-band amplifier design. We believe that this approach also can be used for noise and  $S$ -parameter transformations between CB and CE configurations of other bipolar transistors. Therefore, a low-noise amplifier (LNA) can be built with any of the CE or CB configurations or combination thereof.

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